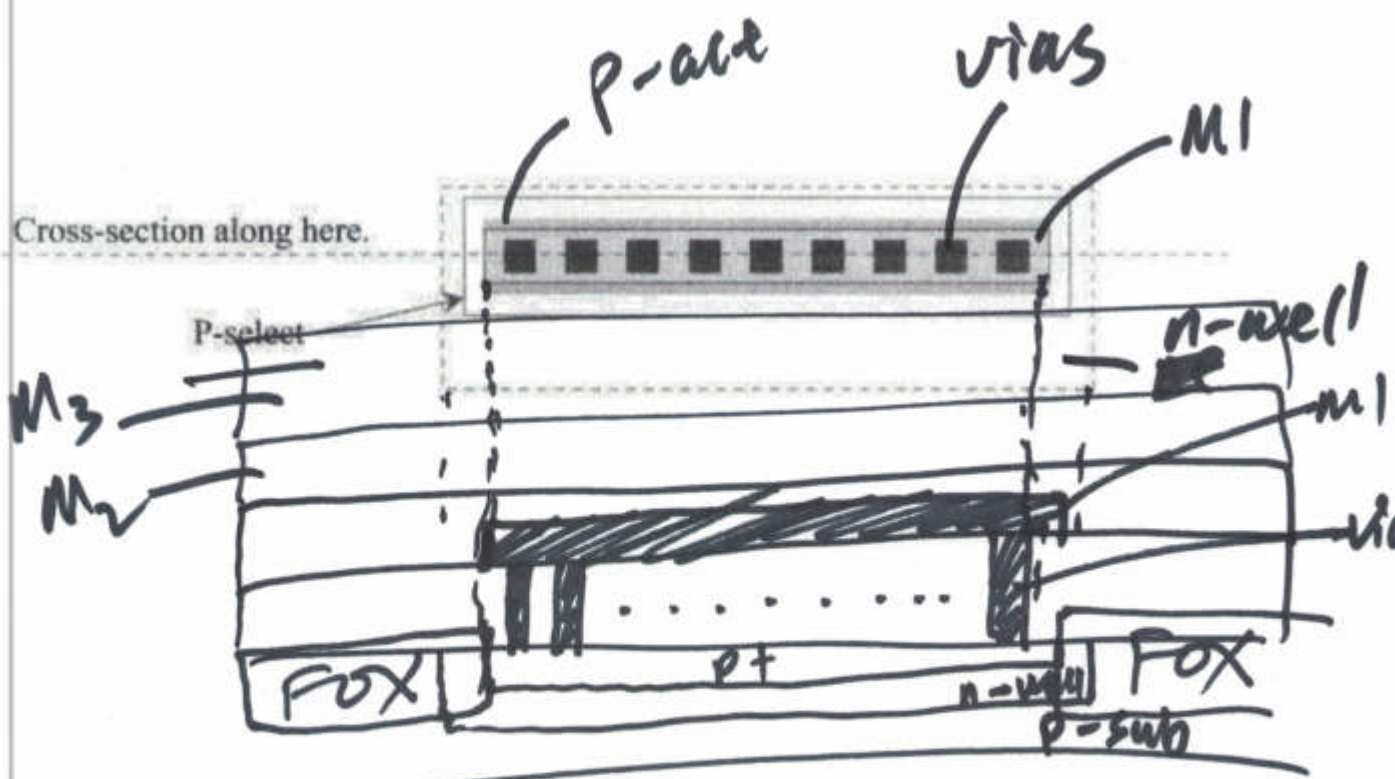
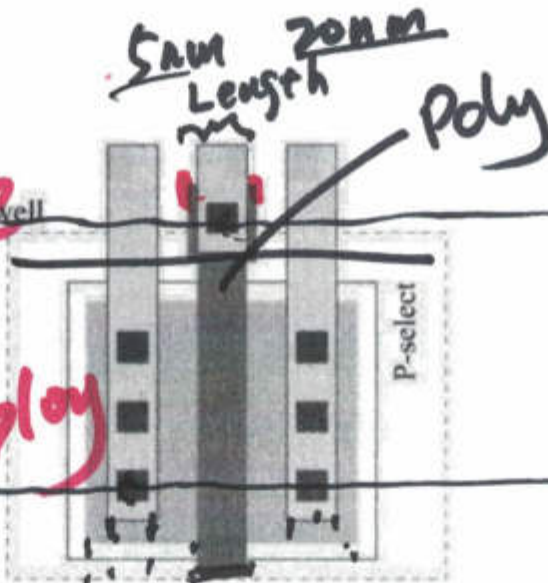


Cross-section along here.

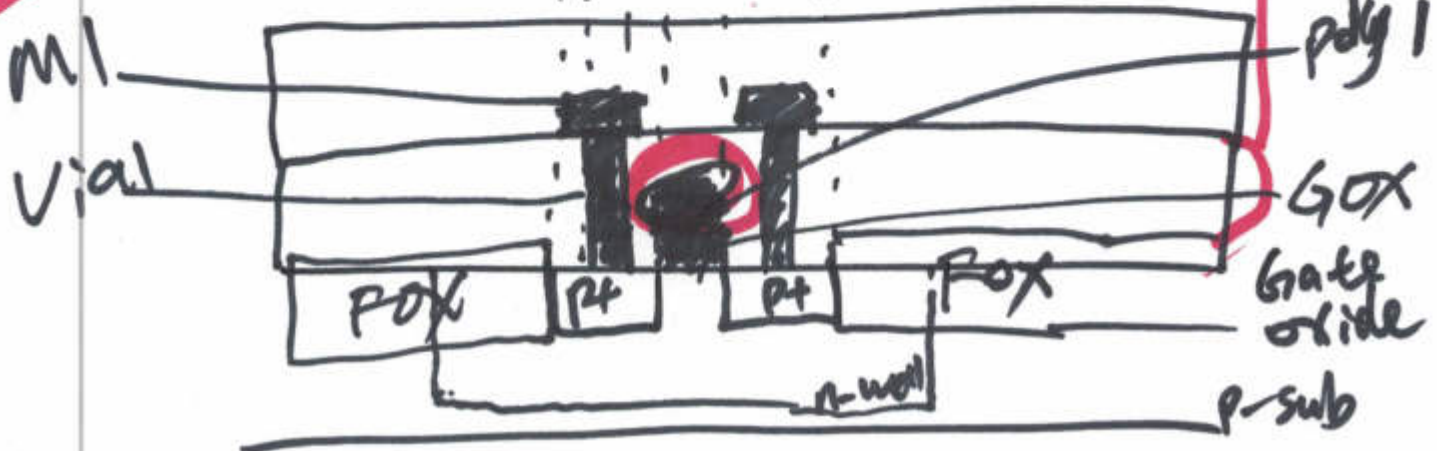


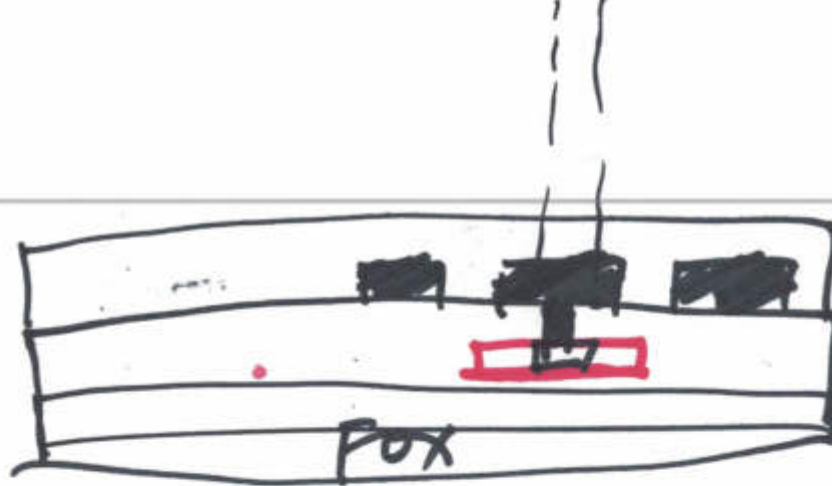
poly

silicide
(meant)
to reduce
resistance of poly
poly silicon



SiO_2





R_{sub}

FinFET 20 nm
5 nm

